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Nanosecond Repetitively Pulsed Glow Discharges in Atmospheric Pressure Air at 300K

Motivation



- **High** $E/N \rightarrow$ High density of reactive species



2. Experimental Setup

Discharge characteristics

FID Technology FPG 30-100MS Pulser *f*=1-100kHz, *V*=5-30kV Pulse duration τ_{90} =10ns Flow: dry air (3%), v=1-10 m/s

Ozone UV absorption spectroscopy



9. References

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